

Electronic Acknowledgement Receipt

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Title of Invention:	SYSTEMS FOR INSPECTING WAFERS AND RETICLES WITH INCREASED RESOLUTION
First Named Inventor:	Steven R. Lange
Customer Number:	35617
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Post Allowance Communication - Incoming	Comments_NOA.pdf	85929	no	1

Warnings:		
Information:		
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